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Patent

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of Vladimir Voronkov et al.

Group Art 2812

Serial No. 09/972,608

Filed October 5, 2001

Confirmation No. 4591

For METHOD FOR THE PRODUCTION OF LOW DEFECT DENSITY SILICON

January 9, 2002

Office of Initial Patent Examination's  
Customer Service Center  
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Washington, D.C. 20231

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SUPPLEMENTAL APPLICATION DATA SHEET

SIR:

Applicants listed incorrect priority information on the Application Data Sheet filed on October 5, 2001 respecting the above-referenced application. In accordance with 37 CFR 1.76(d)(3) & (4), Applicants respectfully submit herewith a Supplemental Application Data Sheet and request that the bibliographical data be recaptured to correctly reflect the priority information in the present application. Applicants also respectfully request a corrected filing receipt reflecting this correction.

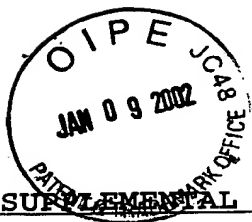
Respectfully submitted,

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SUPPLEMENTAL APPLICATION DATA SHEET

**Application Information**

Application Type:: Regular  
Subject Matter:: Utility  
Title:: A METHOD FOR THE PRODUCTION OF  
LOW DEFECT DENSITY SILICON  
Attorney Docket Number:: MEMC 98-5401/2340.1  
Total Drawing Sheets:: 3  
Small Entity?: No

**Applicant Information**

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**Correspondence Information**

Correspondence Customer Number:: 000321

**Representative Information**

Representative Customer Number:: 000321

**Domestic Priority Information**

Application::	Continuity Type::	Parent Application::	Parent Filing Date::
This application	Non- Provisional of	60/252,715	11/22/00
This application	Non- Provisional of	60/245,610	11/3/00

#### Assignee Information

Assignee Name::

MEMC Electronic Materials, Inc.